Application No.: 10/629,695

AMENDMENTS TO THE SPECIFICATION

On page 1, please amend the title as follows:

METHOD OF MANUFACTURING <u>A</u> SEMICONDUCTOR DEVICE <u>WITH</u>

<u>PENETRATION ELECTRODES THAT PROTRUDE FROM A REAR SIDE OF A SUBSTRATE</u>

<u>FORMED BY THINNING THE SUBSTRATE</u>